

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

FUKUDA, Masatoshi et al.

Serial No.: 10/020,951

Filed: December 19, 2001

d. December 10, 2001

SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING THE SAME

Group Art Unit

Examiner: LANDAU, M.

Date: January 28, 2003

TECHNOLOGY CENTER 2800

P.T.O. Confirmation No.: 8648

PETITION FOR EXTENSION OF TIME

Commissioner for Patents Washington, D.C. 20231

Sir:

For.

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated October 1, 2002 for one month from January 1, 2003 to February 1, 2003.

Attached please find a check in the amount of \$110.00 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit

Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, WESTERMAN & HATTORI, LLP

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PATENT TRADEMARK OFFICE

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